



In re application of

: Confirmation No. 3771

Yoichiro NUMASAWA et al.

Attorney Docket No. 2003_1106A

Serial No. 10/642,619

: Group Art Unit 1754

Filed August 19, 2003

Examiner Ngoc Yen M. Nguyen

APPARATUS AND METHOD FOR MANUFACTURING HALOGEN GAS AND HALOGEN GAS RECOVERY AND CIRCULATORY SYSTEM Mail Stop: Amendment

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Petition hereby is made for a five month extension of time to respond to the communication of September 13, 2005.

The fee of \$2,160.00 is

- (X) submitted herewith.
- () to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.
- () Small entity status of this application is established by a Small Entity Status Assertion which
 - () is enclosed.
 - () has been previously submitted.

Respectfully submitted,

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT

ACCOUNT NO. 23-0975

Yoichiro NUMASAWA et al.

03/14/2006 JADDO1

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2160.00 OP

Jay F Williams

Registration No.48,036 Attorney for Applicants

JFW/akl Washington, D.C. 20006-1021 Telephone (202) 721-8200 Facsimile (202) 721-8250 March 13, 2006